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CONFIRMATION NO. 4213

SERIAL NUMBER 10/511,883	FILING OR 371(c) DATE 10/19/2004 RULE	CLASS 118	GROUP ART UNIT 1734	ATTORNEY DOCKET NO. YPL-0108
APPLICANTS Young Hoon Park, Kyungki-do, KOREA, REPUBLIC OF; Hong Joo Lim, Kyungki-do, KOREA, REPUBLIC OF; Sang Kyu Lee, Kyungki-do, KOREA, REPUBLIC OF; Hyun Soo Kyung, Kyungki-do, KOREA, REPUBLIC OF; Jang Ho Bae, Kyungki-do, KOREA, REPUBLIC OF;				
** CONTINUING DATA ***** This application is a 371 of PCT/KR03/00786 04/17/2003				
** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 10-2002-0021554 04/19/2002				
** SMALL ENTITY **				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 4	TOTAL CLAIMS 13
Verified and Acknowledged Examiner's Signature _____ Initials _____	INDEPENDENT CLAIMS 1			
ADDRESS 23413				
TITLE Apparatus and method for depositing thin film on wafer using remote plasma				
FILING FEE RECEIVED 555	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	